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CONFIRMATION NO. 6245

| SERIAL NUMBER 10/650,193 | FILING OR 371(c) DATE 08/28/2003 RULE | CLASS 257 | GROUP ART UNIT 2826 | ATTORNEY DOCKET NO. Q77191 |
|---|---|------------------------------|--|--|
| APPLICANTS Koichi Ohto, Kanagawa, JAPAN; Toshiyuki Takewaki, Kanagawa, JAPAN; Tatsuya Usami, Kanagawa, JAPAN; Nobuyki Yamanishi, Kanagawa, JAPAN; | | | | |
| ** CONTINUING DATA ***** This application is a CIP of 10/281,321 10/28/2002 ABN | | | | |
| ** FOREIGN APPLICATIONS ***** JAPAN 2002-132780 05/08/2002 JAPAN 2002-302841 10/17/2002 JAPAN 2003-130484 05/05/2003 | | | | |
| IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 11/28/2003 | | | | |
| Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verifed and Acknowledged <u>Allowance</u> Examiner's Signature Initials | | STATE OR COUNTRY JAPAN | SHEETS DRAWING 87 | TOTAL CLAIMS. 212 INDEPENDENT CLAIMS 17 |
| ADDRESS 23373 | | | | |
| TITLE Semiconductor device having silicon-diffused metal wiring layer and its manufacturing method | | | | |
| FILING FEE RECEIVED 6232 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | |